

INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)		Docket Number (Optional) SCP-9410		Application Number 10/620,895	
		Applicant(s) Akshey Seghal			
		Filing Date July 16, 2003		Group Art Unit 1746	

NOV 26 2003

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE
BS	AA	4,944,837	07/31/1990	Nishikawa et al.	156	646	02/28/1989
BS	*AB	5,013,366	05/07/1991	Jackson et al.	134	1	12/07/1988
BS	AC	5,068,040	11/26/1991	Jackson	218	748	04/03/1989
BS	*AD	5,313,965	05/24/1994	Palen	134	61	06/01/1992
BS	AE	5,337,446	08/16/1994	Smith et al.	15	21.1	10/27/1992
BS	AF	5,355,901	10/18/1994	Mielnik et al.	134	105	10/27/1992
BS	*AG	5,377,705	01/03/1995	Smith, Jr. et al.	134	95.3	09/16/1993
BS	*AH	5,401,322	03/28/1995	Marshall	134	13	06/30/1992
BS	AI	5,456,759	10/10/1995	Stanford, Jr. et al.	134	1	08/01/1994
BS	AJ	5,522,938	06/04/1996	O'Brien	134	1	08/08/1994
BS	*AK	5,629,277	05/13/1997	Pliskha	510	202	10/04/1995
BS	AL	5,665,527	09/09/1997	Allen et al.	430	325	02/03/1997
BS	*AM	5,721,204	02/24/1998	Maxwell et al.	510	206	02/29/1996
BS	*AN	5,783,082	07/21/1998	DeSimone et al.	210	634	11/03/1995
BS	*AO	5,868,856	02/09/1999	Douglas et al.	134	2	07/23/1997
BS	*AP	5,868,862	02/09/1999	Douglas et al.	134	26	07/31/1997
BS	AQ	5,873,948	02/23/1999	Kim	134	19	06/24/1997
BS	AR	5,908,510	06/01/1999	McCullough et al.	134	2	10/16/1996
BS	*AS	5,944,996	08/31/1999	DeSimone et al.	210	634	05/02/1997
BS	*AT	5,976,264	11/02/1999	McCullough et al.	134	2	11/30/1998
BS	*AU	5,980,648	11/09/1999	Adler	134	34	02/14/1992
BS	*AV	6,024,801	02/15/2000	Wallace et al.	134	1	12/09/1996
BS	*AW	6,033,993	03/07/2000	Love, Jr. et al.	438	745	09/23/1997
BS	AX	6,085,762	07/11/2000	Barton	134	25.4	02/02/1999
BS	*AY	6,149,828	11/21/2000	Vaartstra	216	57	05/05/1997
BS	*AZ	6,239,090	05/29/2001	Marquis et al.	510	201	12/10/1999
BS	BA	6,242,165	06/05/2001	Vaartstra	430	329	08/28/1998
BS	BB	6,286,231	09/11/2001	Bergman et al.	34	410	01/12/2000

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REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
BC	WO 01/33613 A2	05/10/2001	PCT	H01L	21/00		

OTHER DOCUMENTS
(Including Author, Title, Date, Pertinent Pages, Etc.)

BS	*BD	S.B. Williams et al., "Elimination of Solvents and Waste by Using Supercritical Carbon Dioxide in Precision Cleaning," <i>Los Alamos National Laboratory LA-UR-94-3313 (1017)</i> , October 1996, 25 pages in length.
BS	*BE	S. Verhaverbeke, "Photoresist Stripping With/Without O ₃ Assist," <i>CFM Tech, in Uses of Ozone in the Semiconductor Industry, 19th Annual Semiconductor Pure Water and Chemical Conference</i> , March 13, 2000, 10 pages in length.
BS	*BF	S. Ojima et al., "Photoresist Stripping Technology Utilizing Water Vapor," <i>2000 Semiconductor Pure Water and Chemical Conference</i> , 2000, pp. 387-398.

Examiner <i>S. Cella</i>	Date Considered <i>6/29/04</i>
Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

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*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE
BG	BG	6,306,564	10/23/2001	Mullee	430	329	05/27/1998
	BH	6,500,605	12/31/2002	Mullee et al.	430	329	10/25/2000
	BI	6,508,887	01/21/2003	Park et al.	134	2	11/21/2000
	BJ	6,509,141	01/21/2003	Mullee	430	329	09/03/1999
	BK	US 2002/0014257	02/07/2002	Chandra et al.	134	19	05/18/2001
BS	BL	US 2002/0026729	03/07/2002	Bergman et al.	34	410	08/07/2001
	BM	US 2002/0128164	09/12/2002	Hara et al.	510	175	11/30/2001

FOREIGN PATENT DOCUMENTS

REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO

OTHER DOCUMENTS
(Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner	<i>S Call</i>	Date Considered	<i>6/24/04</i>
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*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE
AS	CA	6,040,284	03/21/2000	Marquis et al.	510	201	05/22/1998
AS	CB	6,420,327	07/16/2002	Machac, Jr. et al.	510	201	08/09/2000

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REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
AS	WO 02/03143 A2	01/10/2002	PCT	G03F	7/42		

OTHER DOCUMENTS
(Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner	<i>S. Call</i>	Date Considered <i>8/29/04</i>
Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.		